Electronic Acknowledgement Receipt					
EFS ID:	4109707				
Application Number:	10689617				
International Application Number:					
Confirmation Number:	4799				
Title of Invention:	Method for cleaning plasma etching apparatus, method for plasma etching, and method for manufacturing semiconductor device				
First Named Inventor/Applicant Name:	Satoru Okamoto				
Customer Number:	26171				
Filer:	Diana DiBerardino/Paul Stovenour				
Filer Authorized By:	Diana DiBerardino				
Attorney Docket Number:	12732-170001				
Receipt Date:	14-OCT-2008				
Filing Date:	22-OCT-2003				
Time Stamp:	15:14:14				
Application Type:	Utility under 35 USC 111(a)				
Payment information:					

Submitted with Payment	yes
Payment Type	Deposit Account
Payment was successfully received in RAM	\$670
RAM confirmation Number	660
Deposit Account	061050
Authorized User	

File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
--------------------	----------------------	-----------	-------------------------------------	---------------------	---------------------

1 Appeal Brief Filed	Appeal Brief Eilad	127320170001 appeabrie fno 2.	114399	no	47
	pdf	03547ca4389e60d3de6553d560f83632037 61a89		77	
Warnings:					
Information:					
2 Fee Worksheet (PTO-06)	fee-info.pdf	32110	no	2	
		26d0e681eeed70f4a363c2767dd71f3fe0a0 0e25			
Warnings:					
Information:					
		Total Files Size (in bytes)	146509		

This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.

New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.